PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a) (Large Entity)				(a)	Docket No. 13647
In Re Application Of: Wadgi W. Abadeer FEB 2 7 2004					
Serial No. 09/811,915	Filing Date 3/19/01	PADEMA'	Examine Vinh P. Ngu		Group Art Unit 2829
Invention: A WAFER LEVEL SYSTEM FOR PRODUCING BURN-IN/SCREEN, AND RELIABILITY BE PERFORMED ON ALL CHIPS SIMULTANEOUSLY WITHOUT ANY WAFER CONTACTING					
TO THE COMMISSIONER FOR PATENTS: This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of 10/20/03 above-identified application.					
The requested extension is as follows (check time period desired):					
☐ One month	☑ Two months	☐ Three r	months 🗆	Four mor	nths Five months
from:	1/20/04 Date	unti	l:	3/20/ Dat	
☑ The Director is hereDeposit Account N☑ If an additional ext	ount of the fee is enclosed eby authorized to charge	d. any fees wh , please con	sider this a petiti	iired, or c	redit any overpayment, to for and charge
3/02/2004 HVUONG1 00000134	090456 09811915				
2 FC:1252 420,00 DA Leopold Presser, Reg. No.	gnatufe PM	Da	ated: February	z 25, 200 4	
SCULLY, SCOTT MURI 400 Garden City Plaza Garden City, NY 11530 (516) 742-4343 LP:ng			on Fet first clas Commis 22313-1	s. 25, 2004 ss mail under sisioner for F 450.	document and fee is being deposited with the U.S. Postal Service as er 37 C.F.R. 1.8 and is addressed to the Patents, P.O. Box 1450, Alexandria, VA
cc:			Typed	or Printed I	Leopold Presser Name of Person Mailing Correspondence